

PATENT
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No. 10/074,884
Confirmation No. 6510

Art Unit: 2826
Examiner: Fazli Erdem

Title: Semiconductor Topography Including a Thin Oxide-Nitride Stack and Method for Making the Same

I hereby certify that this correspondence is being transmitted to the United States Patent & Trademark Office via electronic submission or facsimile on the date indicated below:

11/20/2007 /Pamela Gerik/
Date Pamela Gerik

SUPPLEMENTAL AMENDMENT/RESPONSE TO
FINAL OFFICE ACTION MAILED AUGUST 22, 2007

Dear Sir/Madam:

This paper is submitted as a supplemental response to the final Office Action mailed August 22, 2007 and the subsequent Advisory Action mailed November 7, 2007. The amendment cancels the rejected claims, leaving only the allowed claims as pending in the captioned case.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.